

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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 APPLICANT
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U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US 6,094,305	July 25, 2000	Shiraishi	
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FOREIGN PATENT DOCUMENTS

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EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number & -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
WD	XP009015384	Kim H-J Et Al: "FABRICATION OF DENSE CONTACT PARTTERNS USING HALFTONE PHASE-SHIFTING MASK WITH OFF-AXIS ILLUMINATION" Proceedings of the SPIE. SPIE, Bellingham, VA., US, vol. 2793, 18 June 1996, pages 106-114, XPO09015384 ISSN: 0277-786X

EXAMINER

DATE CONSIDERED

4/20/2004

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